



2-27-06

PATENT
790001-2042

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : NAKAMURA et al.
Serial No. : 10/752,642
Filing Date : January 7, 2004
For : **SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME**
Examiner : Jesse A. Fenty
Art Unit : 2815
Confirmation No. : 4109

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New York, NY 10151

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Date of Deposit: February 24, 2006

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" Service under 37 CFR 1.10 on the date indicated above and is addressed to: **Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

Barnet Shindler

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AMENDMENT UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the November 29, 2005 office action, setting a three month term for reply, please amend the above-identified application as follows: